



**ELECTRONIC COPY**

LG636498719  
Report verification at igi.org

**LABORATORY GROWN DIAMOND REPORT**

May 31, 2024  
IGI Report Number **LG636498719**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **PRINCESS CUT**  
Measurements **7.06 X 6.89 X 4.67 MM**

**GRADING RESULTS**

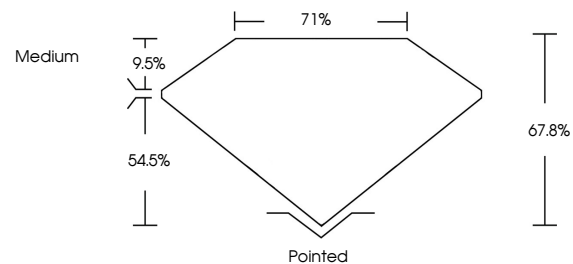
Carat Weight **1.99 CARAT**  
Color Grade **I**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG636498719**

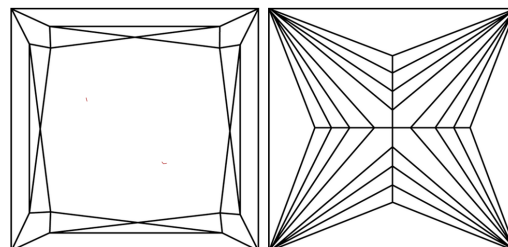
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

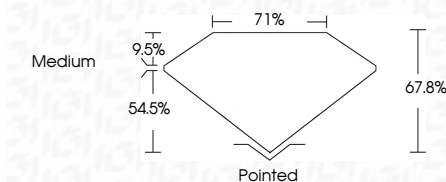
D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**

May 31, 2024  
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**PRINCESS CUT**  
7.06 X 6.89 X 4.67 MM  
Carat Weight **1.99 CARAT**  
Color Grade **I**  
Clarity Grade **VVS 2**  
Depth **54.5%**  
Table **9.5%**  
Girdle **Medium**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG636498719**

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